Bio

STANFORD ADVISORS

- Stacey Bent, Postdoctoral Faculty Sponsor
- Stacey Bent, Postdoctoral Research Mentor

Publications

PUBLICATIONS

- Plasma-enhanced atomic layer deposition: Correlating O2 plasma parameters and species to blister formation and conformal film growth *JOURNAL OF VACUUM SCIENCE & TECHNOLOGY A*

  Werbrouck, A., van de Kerckhove, K., Depla, D., Poelman, D., Smet, P. F., Dendooven, J., Detavernier, C.

  2021; 39 (6)